Statement of Substance of Interview

[0003] The Examiner graciously talked by phone with the undersigned

representatives for the Applicant on December 17, 2008. Applicant greatly

appreciates the Examiner's willingness to talk. Such willingness is invaluable to

each of us in our common goal of an expedited prosecution of this patent

application.

[0004] During the interview, we discussed how the claim 1 and its dependent

claims differed from the cited references, namely Itokawa (US2001/0033620),

Haung et al. (US6016166), and Negishi et al. (US6717891). Without conceding the

propriety of the rejections and in the interest of expediting prosecution, we also

proposed several possible clarifying amendments.

[0005] We understood the Examiner to tentatively concur with the proposed

amendments to independent claims 25 and 30. Similarly, we understood that the

Examiner was receptive to the proposed arguments, specifically the clarification

regarding the Itokawa reference. However, the Examiner indicated that he would need to review the cited art more carefully and/or do another search, and

requested that the proposed amendments be presented in writing.

[0006] Applicant herein amends the claims in the manner discussed during

the interview. Accordingly, Applicant submits that the pending claims are allowable

over the cited art of record for at least the reasons discussed during the interview.

Serial No.: 10/686,969 Atty Docket No.: MS1-1683US/304534.01 Atty/Agent: Brendan E. Squire REGISTES The Stationer of 42 %

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